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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hideo YOSHIDA et al.
Serial No. : Not yet known (U.S. National Stage of PCT/JP01/06525
filed July 30, 2001)
Filed : Concurrently herewith
For : METHOD OF ELECTROCHEMICAL TREATMENT SUCH
AS ELECTROPLATING, ETC. AND ELECTROCHEMICAL
REACTION APPARATUS THEREOF
Examiner : Not yet known
Group Art Unit : Not yet known

Certificate of Mailing Under 37 CFR 1.8

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C. Bruce Hamburg
(Name)


(Signature)

Assistant Commissioner for Patents
Washington, D.C. 20231

CLAIM OF SMALL-ENTITY STATUS

Sir:

Small entity status is hereby claimed.

Respectfully submitted,

JORDAN AND HAMBURG LLP

By 

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